## <u>Biodata</u>

Name	Dr. Akshdeep Sharma
Designation	Scientist C
Educational qualification	M.Sc Electronic Science from Kurukshetra University Kurukshetra. Ph.D from CSIR-CEERI Pilani
Research area	MEMS micro sensors, NEMS fabrication, semiconductor devices, microelectronics, Electroplating, RF MEMS switches
Recognised Awards/Honors/Fellow	<ul> <li>Early Career Research Award (ECRA) from DST-SERB</li> <li>Industrial Postdoctoral Fellow, CeNSE IISc Bangalore</li> <li>CSIR-SRF, CEERI Pilani</li> </ul>
Projects	Ongoing:
	<ol> <li>Design and Fabrication of MEMS Bionics Sensors for Autonomous Underwater Vehicles (AUVs) (HY/SP/040) (Sponsored by SERB, Outlay: Rs. 43.19 lakhs DoS: 22.03.2019; DoC: 31.03.2022)</li> <li>Development of antennas for Navigation with Indian Constellation (HD/SP/039) (Sponsored by MeitY, Outlay: 262.00 lakhs, DoS: 29.09.2018, DoC: 28.09.2021), Co- Investigator</li> </ol>
Publications/Patents (Past 5 years)	<ol> <li>Gallium-Doped Piezoresistive Sensor With Optimized Focused Ion Beam Implantation Akshdeep Sharma, Suma B.N., K. N. Bhat, A. K. Naik Journal of microelectromechanical systems, Vol. 26, No. 1, February 2017, 127-134.</li> </ol>